



NIT-288

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

N. KOFUJI et al

Serial No. 09/920,834

Group Art Unit: 1765

Filed: August 3, 2001

Examiner: K. C. Chen

For: METHOD AND APPARATUS FOR FABRICATING
SEMICONDUCTOR DEVICES

AMENDMENT

Commissioner for Patents
Alexandria, VA 22313

Sir:

In response to the Office Action dated July 30, 2003,
please amend the above-identified application as follows.

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NOV 03 2003
TC 1700

Do not enter

*Thanks K-CC
11/9/03*

